



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re Patent Application of

Shunpei YAMAZAKI et al.

Serial No. 09/466,828

Filed: December 20, 1999

For: INSULATING FILM AND

METHOD OF PRODUCING

SEMICONDUCTOR DEVICE

) Art Unit: 2818

) Examiner: R. Berry

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G.Say
4-7-03*

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with The United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231 on March 3, 2003.

Adele M. Stamper
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INFORMATION DISCLOSURE STATEMENT

Honorable Commissioner of Patents

Washington, D.C. 20231

Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, Applicant submits herewith a Form PTO-1449 listing references known to Applicant and requests that these references be made of record in the above identified application. Copies of the references listed are submitted herewith in accordance with 37 C.F.R. 1.98(a). This Information Disclosure Statement is being filed concurrently with an RCE and therefore no fee is required.

The Commissioner is hereby authorized to charge fees under 37 C.F.R. §§1.16, 1.17, 1.20(a), 1.20(b), 1.20(c), and 1.20(d) (except the Issue Fee) which may be required now or hereafter, or credit any overpayment to Deposit Account No. 50-2280. A duplicate copy of this sheet is attached.

Respectfully submitted,


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